

UNITED STATES DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

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CENTRAL FAX CENTER
MAR 18 2008

Inventors: HE, Ting et al.
Serial Number: 10/757,302

Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit 1763
Examiner Richard R. Bueker

Atty. Docket No.: 3994994-148069

CONFIRMATION NO. 4457

RESPONSE

TO THE NOTICE OF NON-COMPLIANT AMENDMENT MAILED ON OCTOBER 10, 2007

BY FACSIMILE ON MARCH 18, 2008 TO 571-273-8300

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INTRODUCTORY COMMENTS

To the Honorable Commissioner:

In response to the Notice of Non-Compliant Amendment Mailed on October 10, 2007, claims 11, 12 and 14 are corrected. Pages 5 and 6 of the originally filed Amendment, now including the corrected claims, are resubmitted herewith, attached as the two following pages: